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|--|--|--------------------------------|-----------------------------------|
| Form PTO-1449  |  | Docket Number 245402003400     | Application Number To Be Assigned |
| INFORMATION DISCLOSURE CITATION<br>IN AN APPLICATION |  | Applicant                      | Hiroki UEMURA                     |
| (Use several sheets if necessary)                    |  | Filing Date Herewith           | Group Art Unit To Be Assigned     |
|  |  | Mailing Date November 26, 2001 |                                   |

S-99-190  
J-589-091  
11/26/01

## U.S. PATENT DOCUMENTS

| Examiner Initials | Ref. No. | Date | Document No. | Name | Class | Subclass | Filing Date If Appropriate |
|-------------------|----------|------|--------------|------|-------|----------|----------------------------|
|                   |          |      |              |      |       |          |                            |

## FOREIGN PATENT DOCUMENTS

| Examiner Initials | Ref. No. | Date      | Document No. | Country | Class | Subclass | Translation YES NO |
|-------------------|----------|-----------|--------------|---------|-------|----------|--------------------|
| MS                | 1.       | 3/17/1995 | 07073499 A   | Japan   | —     | —        | Abstract only      |

## OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

| Examiner Initials | Ref. No. | Title |
|-------------------|----------|-------|
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EXAMINER: *Michael Frattaglia*DATE CONSIDERED: *4/22/2009*

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.